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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Mile	Complete If Known			
Application Number	09/787,189			
Filing Date	March 15, 2001			
First Named Inventor	Slater			
Group Art Unit				
Examiner Name				
Attorney Docket Number	5000.113			

U.S. PATENT DOCUMENTS						
	U.S. Patent Document		Name of Patentee or Applicant	Date of Publication of	Pages, Columns, Lines, Where Relevan	
Examiner Initials *				of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear
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Examiner Initials*	Cite ' No.1	For Office ³		nent nd Code ⁵ (known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ₆
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Examiner Signature Whuland Date Considered 01/22/04

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Application Number

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March 15, 2001 Filing Date First Named Inventor Slater Group Art Unit Examiner Name

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OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS						
Examiner	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²			
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